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**Title of
Invention****METHOD OF FABRICATING POLY-CRYSTAL ITO FILM AND
POLYCRYSTAL ITO ELECTRODE**

Application Number :

Date :

First Named Applicant: Mr. Fang-An Shu

Confirmation Number:

Attorney Docket Number: 14150-US-PA

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Submitted By:	Elec. Sign.	Sign. Capacity
Dr. Belinda Lee Registered Number: 46,863	/Belinda Lee/	Agent

Documents being submitted:	Files
us-assignment	14150-usassn.xml us-assignment.xsl us-assignment.dtd 14150ASSIGNMENT1.tif 14150ASSIGNMENT2.tif
us-request	14150-usrequ.xml us-request.dtd us-request.xsl
us-fee-sheet	14150-usfees.xml us-fee-sheet.xsl us-fee-sheet.dtd
us-ids	14150-usidst.xml us-ids.dtd us-ids.xsl
application-body	14150usf.xml application-body.dtd Image1.tif Image2.tif Image3.tif Image4.tif Image5.tif Image6.tif Image7.tif Image8.tif isoamsa.ent isoamsb.ent isoamsc.ent isoamsn.ent isoamso.ent isoamsr.ent isobox.ent isocyr1.ent isocyr2.ent isodia.ent isogr1.ent isogr2.ent isogr3.ent isogr4.ent isolat1.ent isolat2.ent isomfrk.ent isomopf.ent isomscr.ent isonum.ent isopub.ent isotech.ent mathml2.dtd mathml2-qname-1.mod mmlalias.ent

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